

1-21-05

IFW
\$



Appl. No. 10/823,116

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/823,116
Filing Date April 12, 2004
Inventor..... Kevin J. Torek et al.
Assignee..... Micron Technology, Inc.
Group Art Unit..... 1765
Examiner Deo, Duy Vu Nguyen
Attorney's Docket No. MI22-2559
Title: Methods of Removing Material from a Semiconductor Substrate

RESPONSE TO NOVEMBER 10, 2004 OFFICE ACTION

To: Mail Stop Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS

Introductory Comments

In response to the Office Action of November 10, 2004, applicant amends and remarks as follows.

01/26/2005 JADD01 00000033 10023116

01 FC:1051

130.00 OP